

| L Number | Hits | Search Text | DB | Time stamp |
|---------------------|-------------|---|----------------------------------|---------------------|
| 1 | 922 | 438/687.ccls. | USPAT | 2004/09/23 13:04 |
| 2 | 710 | 438/694.ccls. | USPAT | 2004/09/23 13:07 |
| 3 | 1597 | 438/692.ccls. | USPAT | 2004/09/23 13:08 |
| 4 | 606 | 438/669.ccls. | USPAT | 2004/09/23 13:08 |
| 5 | 250 | 438/658.ccls. | USPAT | 2004/09/23 13:09 |
| 6 | 260 | 438/659.ccls. | USPAT | 2004/09/23 13:10 |
| 7 | 197 | 438/645.ccls. | USPAT | 2004/09/23 13:10 |
| 8 | 122 | 438/707.ccls. | USPAT | 2004/09/23 13:11 |
| 9 | 758 | 438/710.ccls. | USPAT | 2004/09/23 13:11 |
| 10 | 658 | 438/720.ccls. | USPAT | 2004/09/23 13:14 |
| 11 | 31 | west-jeffrey\$.in. barth-michael\$.in. zuhoski-steven\$.in. | USPAT | 2004/09/23 13:14 |
| 12 | 11 | west-jeffrey\$.in. barth-michael\$.in. zuhoski-steven\$.in. | US-PGPUB | 2004/09/23 13:14 |
| 13 | 26 | west-jeffrey\$.in. barth-michael\$.in. zuhoski-steven\$.in. | EPO; JPO; DERWENT; IBM_TDB | 2004/09/23 13:14 |
| 14 | 8497 | (copper "cu") same (polish\$6 cmp) | USPAT | 2004/09/23 13:25 |
| 15 | 5430 | ((copper "cu") same (polish\$6 cmp)) and (silane silicon) | USPAT | 2004/09/23 13:24 |
| 16 | 3587 | ((copper "cu") same (polish\$6 cmp)) and (silane silicon)) and ((silane silicon) same (copper "cu")) | USPAT | 2004/09/23 13:16 |
| 17 | 1968 | ((copper "cu") same (polish\$6 cmp)) and (silane silicon)) and ((silane silicon) same (copper "cu"))) and plasma | USPAT | 2004/09/23 13:25 |
| 18 | 567 | ((copper "cu") same (polish\$6 cmp)) and (silane silicon)) and ((silane silicon) same (copper "cu"))) and plasma) and (((copper "cu") adj2 (polish\$6 cmp)) ((polish\$6 cmp) adj2 (copper "cu"))) | USPAT | 2004/09/23 13:24 |
| 19 | 1326 | ((copper "cu") adj2 (polish\$6 cmp)) ((polish\$6 cmp) adj2 (copper "cu"))) | US-PGPUB | 2004/09/23 13:24 |
| 20 | 1086 | ((copper "cu") adj2 (polish\$6 cmp)) ((polish\$6 cmp) adj2 (copper "cu")))) and (silane silicon) | US-PGPUB | 2004/09/23 13:26 |
| 22 | 533 | ((copper "cu") adj2 (polish\$6 cmp)) ((polish\$6 cmp) adj2 (copper "cu")))) and (silane silicon)) and plasma | US-PGPUB | 2004/09/23 13:25 |

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|-----------|-------------|--|---|-----------------------------|
| 23 | 4434 | (copper "cu") same (polish\$6 cmp) | EPO; JPO; DERWENT; IBM_TDB | 2004/09/23 13:25 |
| 24 | 483 | ((copper "cu") same (polish\$6 cmp)) and (silane silicon) | EPO; JPO; DERWENT; IBM_TDB | 2004/09/23 13:26 |